

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)
(Large Entity)

Docket No.
SEC.689

In Re Application of Chan-Hoon Park

III 3 0 2001

Serial No
09/484,051

Filing Date
01/18/00

Examiner
ATKINSON, C.

Group Art Unit
3743

Invention: WAFER HEATING APPARATUS HAVING FLUID HEAT TRANSFER MEDIUM AND METHOD OF HEATING A WAFER USING THE SAME

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of May 29, 2001 above-identified application.

The requested extension is as follows (check time period desired):

- One month Two months Three months Four months Five months

The fee for the extension of time is \$110 and is to be paid as follows:

- A check in the amount of the fee is enclosed.
 - The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. 50-0238
A duplicate copy of this sheet is enclosed.
 - If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 50-0238
A duplicate copy of this sheet is enclosed.



John C. Scott

Signature

ADAM C. VOLENTINE
REG. NO. 33289

**JONES VALENTINE, PLLC
12200 SUNRISE VALLEY DRIVE, SUITE 150
RESTON, VA 20191**

TEL. NO. (703) 715-0870

CC:

110.00 OP
110.00 OP

Dated: JULY 30, 2001

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TC 3700 MAIL ROOM

I certify that this document and fee is being deposited on [REDACTED] with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence